



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

<u>In re application of:</u> Kangguo Cheng	<u>Filed:</u> 09/16/2003 <u>Examiner:</u> K. L. Rose
<u>Serial No.</u> 10/605227	<u>Group Art Unit:</u> 2822
<u>Title:</u> Method and Structure of Vertical Strained Silicon Devices	<u>Docket #:</u> FIS920030221US1

AMENDMENT

Commissioner of Patents & Trademarks
Alexandria, VA 22313

Sir:

Responsive to the Office Action of 07/26/2004, please amend the above identified application as follows: